

Attorney Docket No. 071469-0304673
Client Reference: RAJ-003A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Noriaki FUKIAGE

Application No.:

Confirmation

No:

Filed: August 21, 2003

Group No.:

Examiner

For: Method and Apparatus for Depositing Materials with Tunable Optical Properties and Etching Characteristics

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: Noriaki FUKIAGE
Citizenship: JAPAN
Residence: 50 E. Hartsdale Avenue, Apt. 3C, Hartsdale, NY 10530

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: Method and Apparatus for Depositing Materials with Tunable Optical Properties and Etching Characteristics

Docket number assigned to this application: 071469-0304673

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 4

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited
3-6, Akasaka 5-chome, Minato-ku
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JAPAN

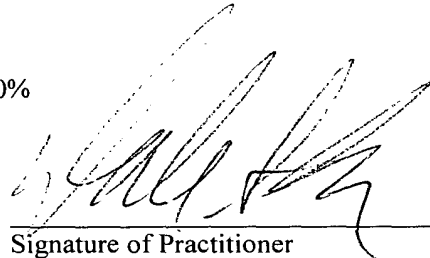
Extent of interest of assignee in application: 100%

Date: August 21, 2003

Reg. No.: 28872

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Signature of Practitioner
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